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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 4502**
Norihito TSUKAHARA et al. : Attorney Docket No. 2003_1827
Serial No. 10/736,568 : Group Art Unit 2891
Filed December 17, 2003 : Examiner Caridad Everhart
SEMICONDUCTOR DEVICE PACKAGE : **Mail Stop: AF**
MANUFACTURING METHOD AND
SEMICONDUCTOR DEVICE PACKAGE
MANUFACTURED BY THE METHOD

Corres. and Mail
BOX AF

RESPONSE UNDER 37. CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2891

AMENDMENT AFTER FINAL

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of January 11, 2006, please amend the above-referenced
U.S. patent application as follows: